

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention

[SILICON OXIDE GAP-FILLING PROCESS]

Application Number :

Confirmation Number:

First Named Applicant: Hsiu-Chuan Chu

Attorney Docket Number: 12157-US-PA-X

Art Unit:

Examiner:

Search string: (5872058 or 6030881 or 6335261).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5872058	1999-02-16	Van Cleemput; Patrick A.		438692	H01C71302
	2	6030881	2000-02-29	Papasouliotis; George D.		438424	H01L21762
	3	6335261	2002-01-01	Natzle; Wesley		438435	H01L2100

Signature

Examiner Name	Date